

PATENT
ATTORNEY DOCKET: 46884-5345



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Satoshi MATSUMOTO et al.) Confirmation No.: 8192
)
Application No.: 10/518,392) Group Art Unit: 2855
)
Filed: July 25, 2005) Examiner: Gail K. Verbitsky
)
For: LASER PROCESSING APPARATUS,)
LASER PROCESSING)
TEMPERATURE MEASURING)
APPARATUS, LASER)
PROCESSING METHOD, AND)
LASER PROCESSING)
TEMPERATURE MEASURING)
METHOD)

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Window, Mail Stop AF
Alexandria, VA 22314

Sir:

**NOTICE OF APPEAL TO THE
BOARD OF PATENT APPEALS AND INTERFERENCES**

Applicants hereby appeal to the Board of Patent Appeals and Interferences from the
decision of the Examiner dated April 3, 2008 finally rejecting claims 8-14.

1. Extension of Time

10/03/2008 SZEWDIE1 00000005 10518392

The proceedings herein are for a patent application and the provisions of 37 C.F.R. § 1.136(a) apply.

01 FC:1401 540.00 OP
02 FC:1253 1110.00 OP

- ☐ Applicants believe that no extension of time is required. However, this conditional petition is being made to provide for the possibility that Applicants have inadvertently overlooked the need for a petition and fee for extension of time.